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JUN 23 2004

**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**

Attorney Docket Number	6395-61264-01
Application Number	10/001,268
Filing Date	November 13, 2001
First Named Inventor	Gagnon, et al.
Art Unit	2621
Examiner Name	Unknown

U.S. PATENT DOCUMENTS

Examiner's Initials*	Cite No. (optional)	Number	Date	Name
		5,587,833	December 24, 1996	Kamentsky
		5,793,969	August 11, 1998	Kamentsky et al.
		6,226,392 B1	May 1, 2001	Bacus et al.
		6,272,235 B1	August 7, 2001	Bacus et al.
		6,396,941 B1	May 28, 2002	Bacus et al.
		6,404,906 B2	June 11, 2002	Bacus et al.
		6,466,690 B2	October 15, 2002	Bacus et al.
		6,522,774 B1	February 18, 2003	Bacus et al.
		US 2001/0050999 A1	December 13, 2001	Bacus et al.
		US 2002/0061127 A1	May 23, 2002	Bacus et al.
		US 2002/0135678 A1	September 26, 2002	Bacus et al.
		US 2003/0123717 A1	July 3, 2003	Bacus et al.

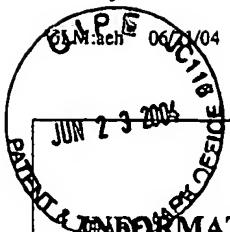
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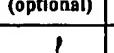
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Examiner's Initials	Cite No. (optional)	OTHER DOCUMENTS
		<p>“AUDF Funds Software Project,” Sept/Oct 1996 ITS Newsletter, 3 pages, http://www.its.unimelb.edu.au/newsletter/1996/September-October/AUDF.html, October 8, 1996.</p>
		<p>Afework et al., “Digital Dynamic Telepathology - the Virtual Microscope,” In Proceedings of the AMIA ’98 Fall Symposium, 5 pages, 1998.</p>
		<p>Ferreira et al., “The Virtual Microscope,” In Proceeding of the AMIA Annual Fall Symposium, pages 449-453, October 1997.</p>

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